

Search Notes**Application/Control No.**

09/590,027

Examiner

Chau Nguyen

Applicant(s)/Patent under Reexamination

KLEIMAN, STEVEN R.

Art Unit

2176

SEARCHED

Class	Subclass	Date	Examiner
709	203	5/20/2003	CN
709	212	5/20/2003	CN
709	228	5/20/2003	CN
709	238	5/20/2003	CN
710	52-53	12/30/2005	CN
710	56	12/30/2005	CN
710	308	12/30/2005	CN
710	310	12/30/2005	CN

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East Reports	05/02/2003	CN
	05/18/2003	CN
	05/19/2003	CN
	05/20/2003	CN
	05/21/2003	CN
	05/22/2003	CN
	05/23/2003	CN
Updated search on East Reports	12/30/2003	CN

Search Notes (continued)

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Class	Subclass	Date	Examiner
709	213	8/9/2005	CN
709	232	8/9/2005	CN
709	238	8/9/2005	CN
710	56	8/9/2005	CN
710	310	8/9/2005	CN
711	171	8/9/2005	CN

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Updated Search on East Reports	08/20/2004	CN
	8/22/2004	CN
Updated Search on East Report	02/23/2005	CN
	02/24/2005	CN
	02/25//2005	CN
Updated Search on East Report	08/09/2005	CN
Updated Search on East Report	12/30/2005	CN
NPL Search on IEEE Database	12/30/2005	CN

INTERFERENCE SEARCHED

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